



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Atsushi YAMAGUCHI

Group Art Unit: 2851

Application No.: 10/588,163

Examiner: P. KIM

Filed: August 1, 2006

Docket No.: 128939

For: EXPOSURE APPARATUS, EXPOSURE METHOD, POSITION CONTROL
METHOD, AND METHOD FOR PRODUCING DEVICE

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the November 14, 2008 Office Action, please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.